



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Costrini, *et al.*

Docket No.: 2003 P 50795 US

Serial No.: 10/600,034

Art Unit: 1765

Filed: June 20, 2003

Examiner: Deo, Duy Vu Nguyen

For: Self-Aligned Mask to Reduce Cell Layout Area

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.312

Applicant respectfully requests entry of this amendment after allowance of the application. In particular, Applicant respectfully requests that the current drawings be replaced with the four (4) sheets of formal drawings that are provided herewith.

No new matter has been added by this amendment. If the Examiner should have any questions or feel that a discussion is necessary, the Applicant invites the Examiner to contact Applicant's attorney at the telephone number listed below.

Respectfully submitted,

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October 6, 2005
Date

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